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10/607,912	06/27/2003	Bernard Andre	BREV 13186 DIV	8153

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EXAMINER

STOUFFER, KELLY M

ART UNIT	PAPER NUMBER
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Applicant : Bernard et al.
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Date Mailed : February 21, 2007

ACKNOWLEDGEMENT OF REQUEST

Notice of Allowance/Allowability Mailed

The request for a copy of the initialed PTO 1449, dated June 19, 2006, has been received by the U.S. Patent and Trademark Office.

- Requested copy attached

A handwritten signature in cursive script that reads "A. Marty Willis".

A. Marty Willis
For the Office of Patent Publication

Notice of References Cited	Application/Control No. 09/830,380	Applicant(s)/Patent Under Reexamination ANDRE ET AL	
	Examiner Tamra L. Dicus	Art Unit 1774	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
✓	A	US-5,399,435	03-1995	Ando et al.	428/428
✓	B	US-5,623,375	04-1997	Floch et al.	359/871
✓	C	US-5,691,044	11-1997	Oyama et al.	313/461
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	E	US-			
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FOREIGN PATENT DOCUMENTS

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Notice of References Cited

Part of Paper No. 7

Wes Hunt
Examiner

3/28/15

SHEET ~~XXXXXXXXXX~~ (clm)

INFORMATION DISCLOSURE CITATION <i>(Use several sheets if necessary)</i>		Docket Number (Optional) BREV 13186	Application Number
		Applicant(s) ANDRE et al	
		Filing Date APRIL 25, 2001	Group Art Unit
*EXAMINER INITIAL	OTHER DOCUMENTS <i>(Including Author, Title, Date, Pertinent Pages, Etc.)</i>		
WA	"Optical Coatings Deposited by Reactive Ion Plating" by A.J. Waldorf et al Applied Optics/October 1, 1993/Vol. 32, No. 28 pgs. 5583-5593		
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EXAMINER		DATE CONSIDERED	
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